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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In.re application of

Docket No: Q76591

Takuro NISHIMURA, et al.

Appln. No.: 10/620,412

Group Art Unit: 1724

Confirmation No.: 9610

Examiner: Robert J. Popovics

Filed: July 17, 2003

For: SOLUTION FILM-FORMING METHOD

**NOTICE OF APPEAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated November 30, 2006.

A check for the statutory fee of \$500.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: November 30, 2006

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